

Institution:

Contact person:

E-mail:

Tel. number:

Equipment:	AFM	Ion miller
	ALD	RIE
	EBL	PPMS
	E-beam/thermal evap.	SEM / eSEM
	EDX	TEM
	EELS	Sputter deposition
	Mask Aligner	XRR/XRD
	RAMAN microscopy	Other

Service Mode: Self-service
 Service

Samples amount:

Service
description:

Risk (if any):